

# PHOTOACID GENERATOR, METHOD FOR PRODUCING THE SAME, AND RESIST COMPOSITION COMPRISING THE SAME

## BACKGROUND OF THE INVENTION

### 1. Field of the Invention

The present invention relates to .a photoacid generator, a method for producing the photoacid generator, and a resist composition containing the photoacid generator. More particularly, the present invention relates to a photoacid generator which can maintain an appropriate contact angle at the time of ArF liquid immersion lithography, can reduce the defects occurring during liquid immersion lithography, has excellent solubility in resist solvents and excellent compatibility with resins, and can be produced by an efficient and simple method using an industrially easily available epoxy compound, a method for producing the photoacid generator, and a resist composition containing the photoacid generator.

### 2. Description of the Related Art

Chemically amplified positive resist compositions that are used in the semiconductor microprocessing including a lithographic process, include an acid generator containing a compound which generates acid when irradiated with light.

The acid generator absorbs the light used in semiconductor patterning processes. Onium salts that are mainly used as acid generators are such that the cationic moiety is decomposed into a radical form and comes to exist as a molecule of another form, and the anionic moiety generates acid, so that after irradiation, diffusion occurs on the resist film at the time of baking of the wafer.

During this process, the acid generator directly affects the resolution of the resist,

the line edge roughness and the like by means of various factors such as the ability to absorb light, the acid production efficiency for the acid produced as a result of light absorption, the diffusion capability of the acid generated from the anion, and the strength of the acid generated from the anion.

Furthermore, in order to obtain excellent smoothness, the acid generator used in such chemically amplified resist materials needs to be uniformly dispersed in the resist composition. Therefore, the solubility of acid generators in resist solvents and compatibility thereof with resins are very important. However, conventional photoacid generators are not excellent in the solubility in solvents and the compatibility with resins, it is difficult to produce photoacid generators at low cost.

## SUMMARY OF THE INVENTION

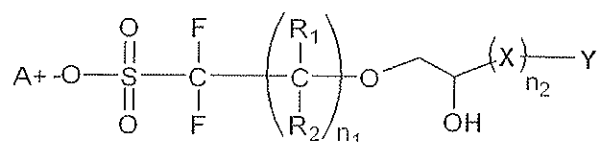
Accordingly, it is an object of the present invention to provide a photoacid generator which can maintain an appropriate contact angle at the time of ArF liquid immersion lithography, can reduce the defects occurring during liquid immersion lithography, and has excellent solubility in resist solvents and excellent compatibility with resins.

Another object of the present invention is to provide a method for producing the photoacid generator described above.

Another object of the present invention is to provide a resist composition containing the photoacid generator described above.

According to an aspect of the present invention, there is provided a photoacid generator represented by the following formula (1):

[Chemical Formula 1]

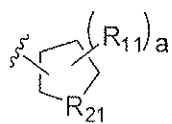


wherein in the formula (1), Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cycloalkyl group, a heterocycloalkyl group, an aryl group and a heteroaryl group; X represents any one selected from the group consisting of an alkanediyl, an alkenediyl, NR', S, O, CO and combinations thereof; R' represents any one selected from the group consisting of a hydrogen atom and an alkyl group; R<sub>1</sub> and R<sub>2</sub> each independently represent a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen group, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group and a thio group; n<sub>1</sub> represents an integer from 1 to 2; n<sub>2</sub> represents an integer from 0 to 5; and A<sup>+</sup> represents an organic counterion.

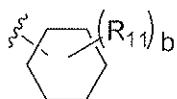
Y may be any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cyclopentyl group, a cyclohexyl group, a decahydronaphthalene group, an octahydro-1H-indene group, an adamantyl group, a norbornyl group, a tetrahydrofuran group, a polycyclic cycloalkyl group containing a norbornyl group having 10 to 30 carbon atoms, a phenyl group, a naphthyl group, a biphenyl group, an anthryl group, a penanthrene group, a fluorenyl group, a pyrene group, a phenalene group, an indene group, a biphenylene group, a diphenylmethyl group, a tetrahydronaphthyl group, a dihydroanthryl group, a tetraphenylmethyl group, and a triphenylmethyl group.

Y may be any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, and groups represented by the following formulas (1-a) to (1-i) and formulas (2-a) to (2-l):

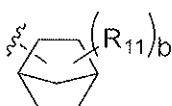
[Chemical Formula 1-a]



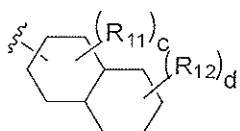
[Chemical Formula 1-b]



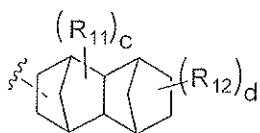
[Chemical Formula 1-c]



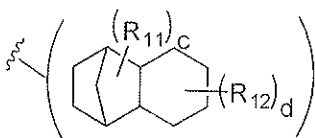
[Chemical Formula 1-d]



[Chemical Formula 1-e]



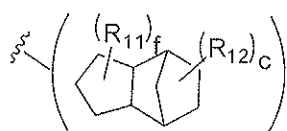
[Chemical Formula 1-f]



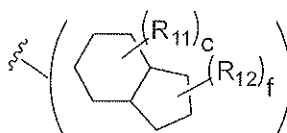
[Chemical Formula 1-g]



[Chemical Formula 1-h]

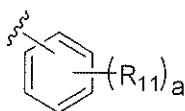


[Chemical Formula 1-i]

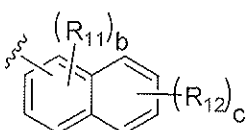


wherein in the formulas (1-a) to (1-i),  $R_{11}$  and  $R_{12}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, a methoxy group,  $OR'$ ,  $COR'$ ,  $COOR'$ , O and S;  $R'$  represents any one selected from the group consisting of an alkyl group and an aryl group;  $R_{21}$  represents any one selected from the group consisting of  $CR_{24}R_{25}$ , O, CO, S and  $NR_{23}$ ;  $R_{23}$  to  $R_{25}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group and an aryl group; a, c and d each independently represent an integer from 0 to 9; b represents an integer from 0 to 11; e represents an integer from 0 to 15; f represents an integer from 0 to 7;  $0 \leq c+d \leq 17$ ; and  $0 \leq c+f \leq 15$ .

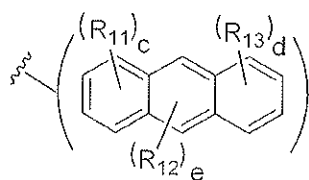
[Chemical Formula 2-a]



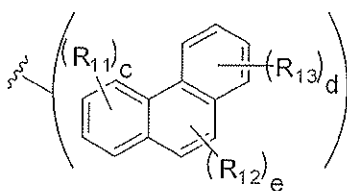
[Chemical Formula 2-b]



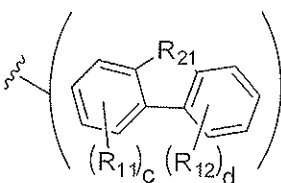
[Chemical Formula 2-c]



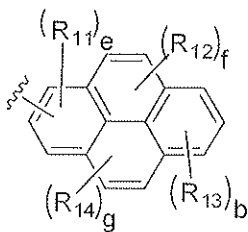
[Chemical Formula 2-d]



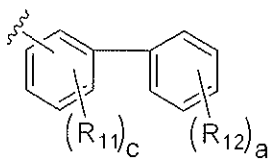
[Chemical Formula 2-e]



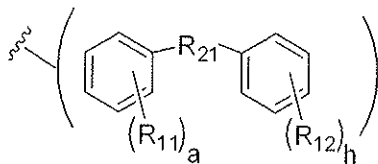
[Chemical Formula 2-f]



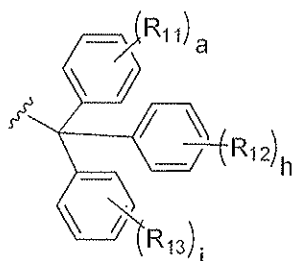
[Chemical Formula 2-g]



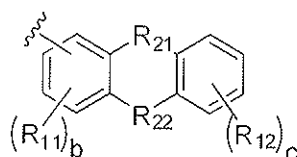
[Chemical Formula 2-h]



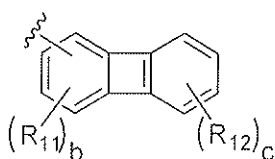
[Chemical Formula 2-i]



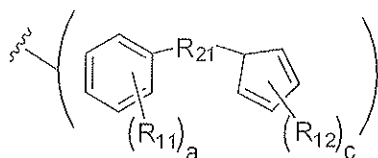
[Chemical Formula 2-j]



[Chemical Formula 2-k]



[Chemical Formula 2-l]

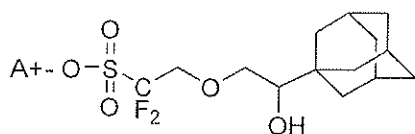


wherein in the formulas (2-a) to (2-l),  $R_{11}$ ,  $R_{12}$ ,  $R_{13}$  and  $R_{14}$  each independently represent any one selected from the group consisting of an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a cyano group, a nitro group, an amino group and a thio group;  $R_{21}$  and  $R_{22}$  each independently represent any one selected from the group consisting of  $CR_{24}R_{25}$ , O, CO, S and  $NR_{23}$ ;  $R_{23}$  to  $R_{25}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, and an aryl group; a, h and i each independently represent

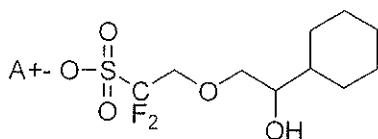
an integer from 0 to 5; b represents an integer from 0 to 3; c and d each independently represent an integer from 0 to 4; e, f and g each independently represent an integer from 0 to 2; and  $0 \leq c+d+e \leq 9$ .

The photoacid generator may be any one selected from the group consisting of compounds represented by the following formulas (3-1) to (3-12):

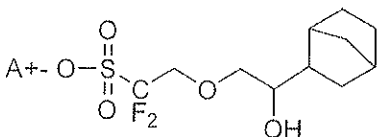
[Chemical Formula 3-1]



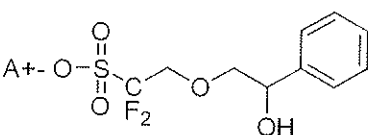
[Chemical Formula 3-2]



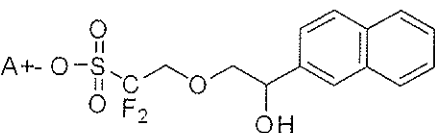
[Chemical Formula 3-3]



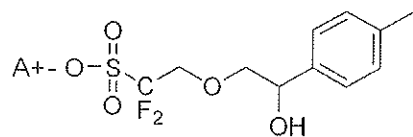
[Chemical Formula 3-4]



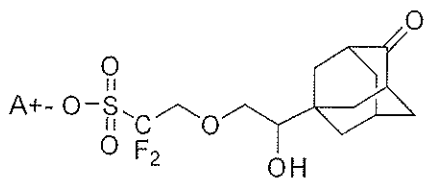
[Chemical Formula 3-5]



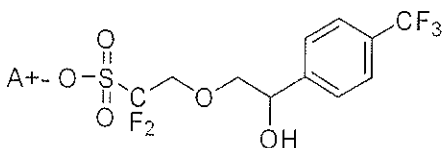
[Chemical Formula 3-6]



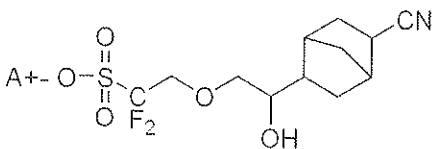
[Chemical Formula 3-7]



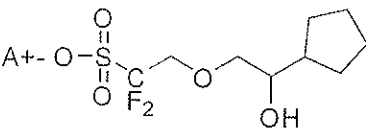
[Chemical Formula 3-8]



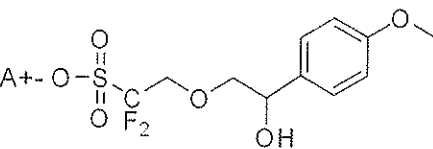
[Chemical Formula 3-9]



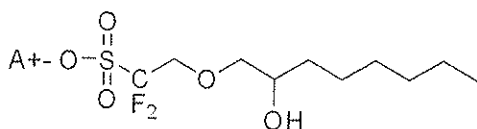
[Chemical Formula 3-10]



[Chemical Formula 3-11]



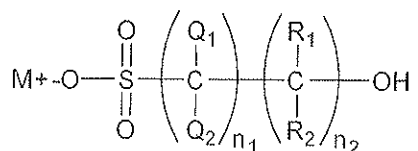
[Chemical Formula 3-12]



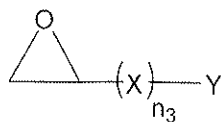
According to another aspect of the present invention, there is provided a method for producing a photoacid generator, including a first step of allowing a hydroxysulfonic acid salt to react with oxirane and thereby producing a hydroxyethoxysulfonic acid salt; and a second step of subjecting the hydroxyethoxysulfonic acid salt thus produced to a substitution reaction of the cation, and thereby producing a compound represented by the formula (1).

The hydroxysulfonic acid salt may be represented by the following formula (6), the oxirane may be represented by the following formula (7), and the hydroxyethoxysulfonic acid salt may be represented by the following formula (8):

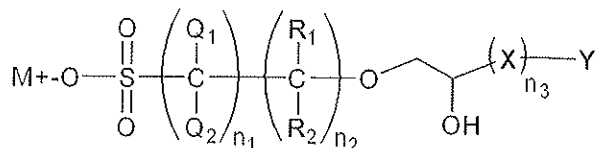
[Chemical Formula 6]



[Chemical Formula 7]



[Chemical Formula 8]



wherein in the formulas (6) to (8), Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cycloalkyl group, a heterocycloalkyl group, an aryl group and a heteroaryl group; X represents any one

selected from the group consisting of an alkanediyl, an alkenediyl,  $\text{NR}'$ , S, O, CO and combinations thereof;  $\text{R}'$  represents any one selected from the group consisting of a hydrogen atom and an alkyl group;  $\text{R}_1$  and  $\text{R}_2$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group and a thio group;  $n_1$  represents an integer from 1 to 5;  $n_2$  represents an integer from 0 to 5; and  $\text{M}^+$  represents an alkali metal ion.

The first step may be carried out by allowing the hydroxysulfonic acid salt to react with oxirane in the presence of an acidic catalyst.

The first step may be carried out by mixing the hydroxysulfonic acid salt and oxirane, and then allowing them to react for 1 to 48 hours at  $0^\circ\text{C}$  to  $100^\circ\text{C}$ .

According to another aspect of the present invention, there is provided a resist composition containing the photoacid generator described above.

## DESCRIPTION OF THE PREFERRED EMBODIMENTS

The definitions of the terms used in the present specification are as follows.

Unless particularly stated otherwise in the present specification, a halogen group means any one selected from the group consisting of fluorine, chloride, bromine and iodine.

Unless particularly stated otherwise herein, an alkyl group includes a primary alkyl group, a secondary alkyl group and a tertiary alkyl group.

Unless particularly stated otherwise herein, an alkanediyl means a divalent atomic group obtained by extracting two hydrogen atoms from an alkane, and can be represented by formula:  $-\text{C}_n\text{H}_{2n}-$ . An alkenediyl means a divalent atomic group obtained by extracting

two hydrogen atoms from an alkene, and can be represented by formula:  $-C_nH_n-$ .

Unless particularly stated otherwise herein, a perfluoroalkyl group means an alkyl group in which a portion or all of hydrogen atoms have been substituted with fluorine, and a perfluoroalkoxy group means an alkoxy group in which a portion or all of hydrogen atoms have been substituted with fluorine.

Unless particularly stated otherwise herein, all compounds or substituents may be substituted or unsubstituted. Here, being "substituted" means that a hydrogen atom has been replaced with any one selected from the group consisting of a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, an alkoxy group, a nitrile group, an aldehyde group, an epoxy group, an ether group, an ester group, a carbonyl group, an acetal group, a ketone group, an alkyl group, a perfluoroalkyl group, a cycloalkyl group, a heterocycloalkyl group, an allyl group, a benzyl group, an aryl group, a heteroaryl group, derivatives thereof, and combinations thereof.

Unless particularly stated otherwise herein, the prefix hetero- means that a carbon atom is substituted with one to three heteroatoms selected from the group consisting of N, O, S, P and CO.

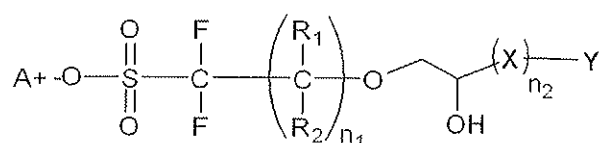
Unless particularly stated otherwise herein, an alkyl group includes a linear or branched alkyl group having 1 to 10 carbon atoms, an alkanediyl means an alkanediyl having 1 to 10 carbon atoms, an alkenediyl means an alkenediyl having 2 to 10 carbon atoms, and an alkoxy group means an alkoxy group having 1 to 10 carbon atoms. A perfluoroalkyl group means a perfluoroalkyl group having 1 to 10 carbon atoms, a perfluoroalkoxy group means a perfluoroalkoxy group having 1 to 10 carbon atoms, a cycloalkyl group means a cycloalkyl group having 3 to 32 carbon atoms, and a heterocycloalkyl group means a heterocycloalkyl group having 2 to 32 carbon atoms. An

aryl group means an aryl group having 6 to 30 carbon atoms, and a heteroaryl group means a heteroaryl group having 2 to 30 carbon atoms.

Hereinafter, the present invention will be described in more detail.

The photoacid generator is represented by the following formula (1):

[Chemical Formula 1]



In the formula (1), R<sub>1</sub> and R<sub>2</sub> each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group and a thio group, and may be preferably a hydrogen atom or an alkyl group.

n<sub>1</sub> represents an integer of 1 or 2, and n<sub>2</sub> represents a integer from 0 to 5, and may be preferably an integer from 0 to 3.

X represents any one selected from the group consisting of an alkanediyl, an alkenediyl, NR', S, O, CO and combinations thereof, and R' represents any one selected from the group consisting of a hydrogen atom and an alkyl group.

Specifically, X may be any one selected from the group consisting of -O-, -OCH<sub>2</sub>-, -OCH(Cl)-, -CO-, -COCH<sub>2</sub>-, -COCH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>-O-, -CH<sub>2</sub>-O-CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-O-, -CH<sub>2</sub>-O-CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-O-CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>CH<sub>2</sub>-O-, -CH<sub>2</sub>-O-CH<sub>2</sub>CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-O-CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>CH<sub>2</sub>-O-CH<sub>2</sub>-, -CH(CH<sub>3</sub>)-, -C(CH<sub>3</sub>)<sub>2</sub>CH<sub>2</sub>-, -CH(CH<sub>3</sub>)CH<sub>2</sub>-, -CH(CH<sub>2</sub>CH<sub>3</sub>)-, -CH(OCH<sub>3</sub>)-, -C(CF<sub>3</sub>)(OCH<sub>3</sub>)-, -CH<sub>2</sub>-S-, -CH<sub>2</sub>-S-CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-S-, -CH<sub>2</sub>-S-CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-S-CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>CH<sub>2</sub>-S-, -CH<sub>2</sub>-S-CH<sub>2</sub>CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>-S-CH<sub>2</sub>CH<sub>2</sub>-, -CH<sub>2</sub>CH<sub>2</sub>CH<sub>2</sub>-S-CH<sub>2</sub>-, -CH(CH<sub>2</sub>)CH-, -C(CH<sub>2</sub>CH<sub>2</sub>)-, -CH<sub>2</sub>CO-, -

CH<sub>2</sub>CH<sub>2</sub>CO-, -CH(CH<sub>3</sub>)CH<sub>2</sub>CO-, -CH(OH)-, -C(OH)(CH<sub>3</sub>)-, -CH(F)-, -CH(Br)-, -CH(Br)CH(Br)-, -CH=CH-, -CH<sub>2</sub>CH=CH-, -CH=CHCH<sub>2</sub>-, -CH=CH-O-, -CH=CH-S- and -CH=CHCO-.

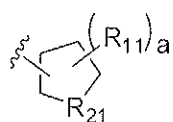
Y may be any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cycloalkyl group, a heterocycloalkyl group, an aryl group, and a heteroaryl group. Specifically, Y may be any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cyclopentyl group, a cyclohexyl group, a decahydronaphthalene group, an octahydro-1H-indene group, an adamantyl group, a norbornyl group, a tetrahydrofuran group, a polycyclic cycloalkyl group containing a norbornyl group having 10 to 30 carbon atoms, a phenyl group, a naphthyl group, a biphenyl group, an anthryl group, a phenanthrene group, a fluorenyl group, a pyrene group, a phenalene group, an indene group, a biphenylene group, a diphenylmethyl group, a tetrahydronaphthyl group, a dihydroanthryl group, a tetraphenylmethyl group and a triphenylmethyl group.

Among the carbon atoms of Y, one to three carbon atoms may be substituted with any one selected from the group consisting of -O-, -CO-, -S- and combinations thereof, and among the hydrogen atoms of Y, one to five hydrogen atoms may be substituted with any one selected from the group consisting of an alkyl group having 1 to 6 carbon atoms, an alkoxy group having 1 to 6 carbon atoms, a perfluoroalkyl group having 1 to 4 carbon atoms, a perfluoroalkoxy group having 1 to 4 carbon atoms, a hydroxyalkyl group having 1 to 6 carbon atoms, a halogen atom, a hydroxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, a methoxy group, OR', COR', COOR', O and S. R' may be any one selected from the group consisting of an alkyl group and an aryl group.

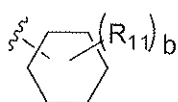
More specifically, Y may be any one selected from the group consisting of an alkyl

group, an alkenyl group, an alkoxy group, and groups represented by the following formulas (1-a) to (1-i) and formulas (2-a) to (2-l):

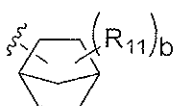
[Chemical Formula 1-a]



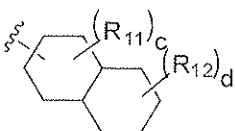
[Chemical Formula 1-b]



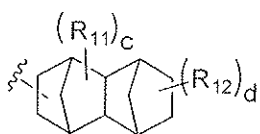
[Chemical Formula 1-c]



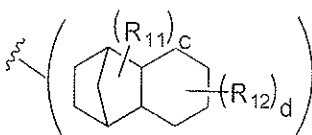
[Chemical Formula 1-d]



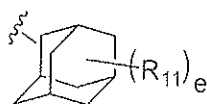
[Chemical Formula 1-e]



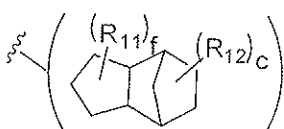
[Chemical Formula 1-f]



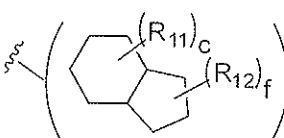
[Chemical Formula 1-g]



[Chemical Formula 1-h]



[Chemical Formula 1-i]



In the formulas (1-a) to (1-i),  $R_{11}$  and  $R_{12}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, a methoxy group,  $OR'$ ,  $COR'$ ,  $COOR'$ , O and S, and  $R'$  represents any one selected from the group consisting of an alkyl group and an aryl group. When  $R_{11}$  or  $R_{12}$  is O or S,  $R_{11}$  or  $R_{12}$  represents a substituent having a double bond.

$R_{21}$  represents any one selected from the group consisting of  $CR_{24}R_{25}$ , O, CO, S and  $NR_{23}$ , and  $R_{23}$  to  $R_{25}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group and an aryl group.

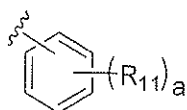
Furthermore, a, c and d each independently represent an integer from 0 to 9; b represents an integer from 0 to 11; e represents an integer from 0 to 15; f represents an integer from 0 to 7; and  $0 \leq c+d \leq 17$ , while  $0 \leq c+f \leq 15$ .

Specifically, in the formulas (1-a), (1-b), (1-d) and (1-g),  $R_{11}$  may represent any one selected from the group consisting of a hydrogen atom, an alkyl group having 1 to 6 carbon atoms, an alkoxy group having 1 to 6 carbon atoms, a perfluoroalkyl group having

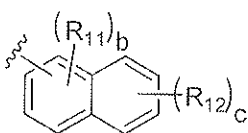
1 to 4 carbon atoms, a perfluoroalkoxy group having 1 to 4 carbon atoms, a hydroxyalkyl group having 1 to 6 carbon atoms, a halogen atom, a hydroxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, and a methoxy group.

Furthermore, in the formulas (1-c), (1-e), (1-f), (1-h) and (1-i),  $R_{11}$  and  $R_{12}$  may each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group having 1 to 6 carbon atoms, an alkoxy group having 1 to 6 carbon atoms, a perfluoroalkyl group having 1 to 4 carbon atoms, a perfluoroalkoxy group having 1 to 4 carbon atoms, a hydroxyalkyl group having 1 to 6 carbon atoms, a halogen atom, a hydroxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, a methoxy group and combinations thereof.

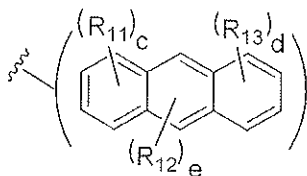
[Chemical Formula 2-a]



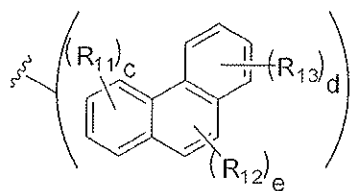
[Chemical Formula 2-b]



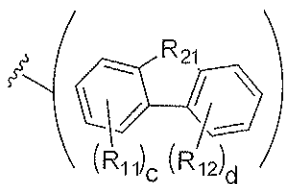
[Chemical Formula 2-c]



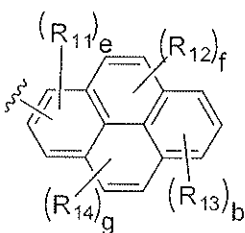
[Chemical Formula 2-d]



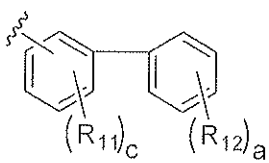
[Chemical Formula 2-e]



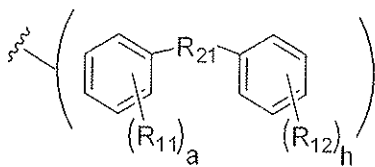
[Chemical Formula 2-f]



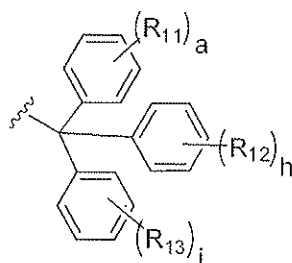
[Chemical Formula 2-g]



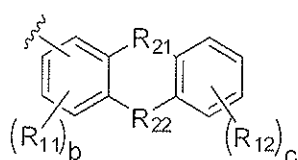
[Chemical Formula 2-h]



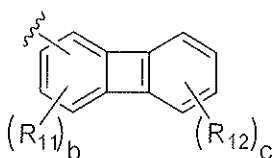
[Chemical Formula 2-i]



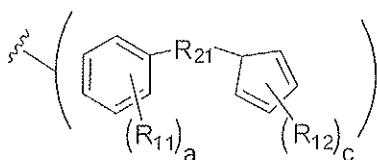
[Chemical Formula 2-j]



[Chemical Formula 2-k]



[Chemical Formula 2-l]



In the formulas (2-a) to (2-l),  $R_{11}$ ,  $R_{12}$ ,  $R_{13}$  and  $R_{14}$  each independently represent any one selected from the group consisting of an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, a methoxy group, OR, COR' and COOR', and R' represents any one selected from the group consisting of an alkyl group and an aryl group.

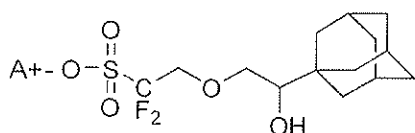
$R_{21}$  and  $R_{22}$  each independently represent any one selected from the group consisting of  $CR_{24}R_{25}$ , O, CO, S and  $NR_{23}$ , and  $R_{23}$  to  $R_{25}$  each independently represent

any one selected from the group consisting of a hydrogen atom, an alkyl group and an aryl group.

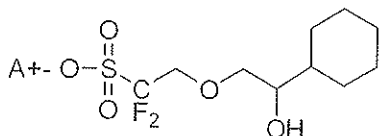
a, h and i each independently represent an integer from 0 to 5; b represents an integer from 0 to 3; c and d each independently represent an integer from 0 to 4; e, f and g each independently represent an integer from 0 to 2; and  $0 \leq c+d+e \leq 9$ .

Specifically, the photoacid generator may be any one selected from the group consisting of compounds represented by the following formulas (3-1) to (3-12):

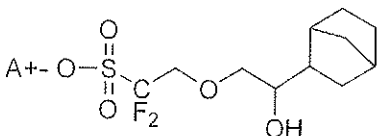
[Chemical Formula 3-1]



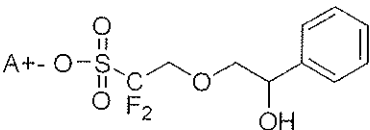
[Chemical Formula 3-2]



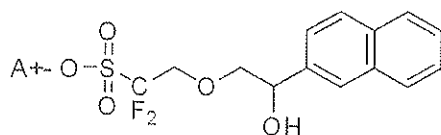
[Chemical Formula 3-3]



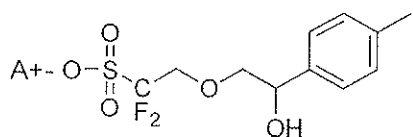
[Chemical Formula 3-4]



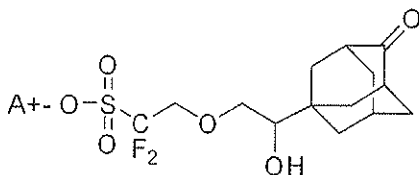
[Chemical Formula 3-5]



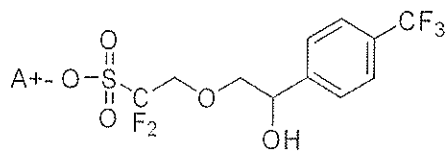
[Chemical Formula 3-6]



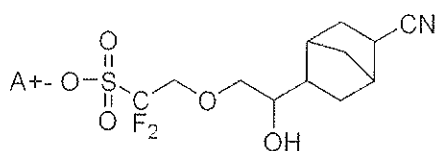
[Chemical Formula 3-7]



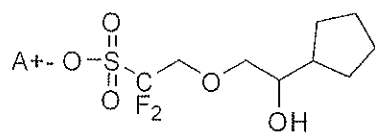
[Chemical Formula 3-8]



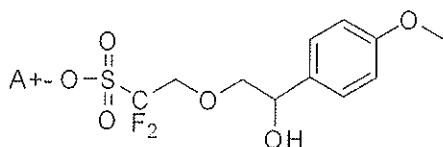
[Chemical Formula 3-9]



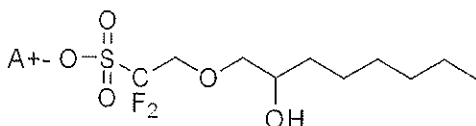
[Chemical Formula 3-10]



[Chemical Formula 3-11]



[Chemical Formula 3-12]

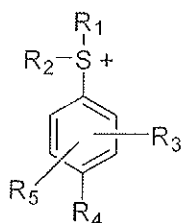


The photoacid generator is a compound represented by a sulfonic acid onium salt having a hydroxy skeleton, and such a compound can also effective function as a photoacid generator for chemically amplified resist materials. Furthermore, the photoacid generator can maintain an appropriate contact angle at the time of ArF liquid immersion lithography, can reduce defects occurring during liquid immersion lithography, and has excellent solubility in resist solvents and excellent compatibility with resins.

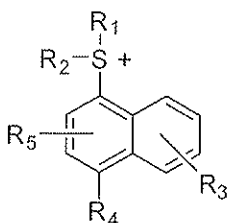
Furthermore, the photoacid generator is a radiation-sensitive acid generator which responds to active radiation, particularly far-ultraviolet radiation or an electron beam, which are represented by KrF excimer laser light, ArF excimer laser light, or extreme ultraviolet (EUV) radiation. The photoacid generator exhibits satisfactory combustibility, has no problem of accumulation in human body, and has sufficiently high acidity of the acid generated (light-generated acid). The acid generated has an appropriate boiling point, and also has an appropriate short length of diffusion in the resist film. Furthermore, the photoacid generator has excellent solubility in resist solvents and excellent compatibility with resins, and can be easily produced by inexpensive methods.

In the formula (1),  $A^+$  is an organic counterion, and its type is not particularly limited in the present invention. However, an example of an ion that can be used as the organic counterion may be any one selected from the group consisting of ions represented by the following formulas (4a) and (4b):

[Chemical Formula 4a]



[Chemical Formula 4b]



In the formulas (4a) and (4b),  $R_1$  and  $R_2$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an allyl group, a perfluoroalkyl group, an aryl group and combinations thereof;  $R_1$  and  $R_2$  can also be joined to form a saturated or unsaturated hydrocarbon ring having 3 to 30 carbon atoms.

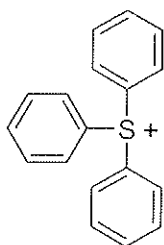
$R_4$  represents any one selected from the group consisting of a halogen atom, an alkyl group, an alkoxy group, an aryl group, a thioalkoxy group, alkoxycarbonylmethoxy group, a thiophenoxy group, and combinations thereof.

$R_3$  and  $R_5$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an allyl group, a perfluoroalkyl group, an aryl group and combinations thereof.

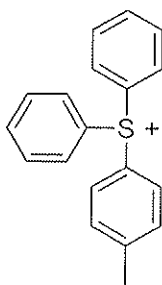
In the formulas (4a) and (4b), examples of the alkyl group include a methyl group, an ethyl group, a propyl group, an isopropyl group, an n-butyl group, a phenyl group, a hexyl group, and an octyl group, and examples of the alkoxy group include a methoxy group, an ethoxy group, a propoxy group, a butoxy group, a hexyloxy group, and an octyloxy group.

The organic counterion represented by the formula (4a) or (4b) may be any one selected from the group consisting of ions represented by the following formulas (4-i) to (4-xx):

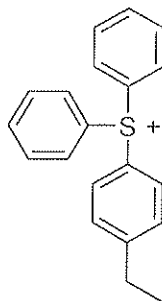
[Chemical Formula 4-i]



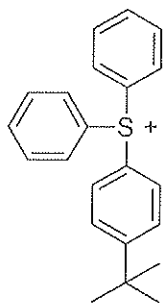
[Chemical Formula 4-ii]



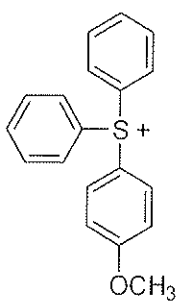
[Chemical Formula 4-iii]



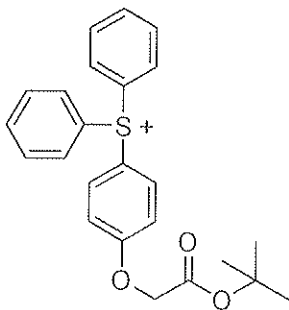
[Chemical Formula 4-iv]



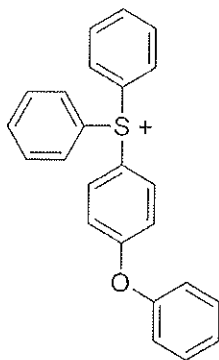
[Chemical Formula 4-v]



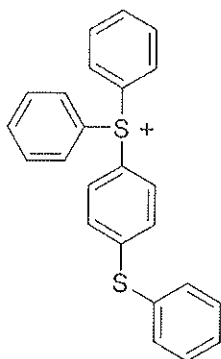
[Chemical Formula 4-vi]



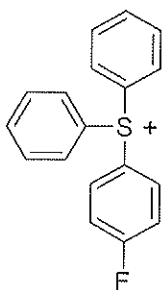
[Chemical Formula 4-vii]



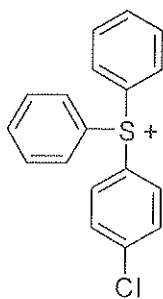
[Chemical Formula 4-viii]



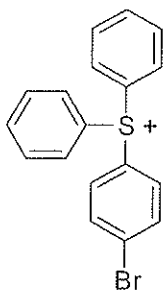
[Chemical Formula 4-ix]



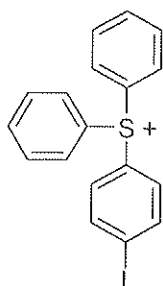
[Chemical Formula 4-x]



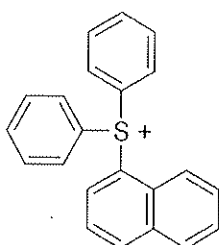
[Chemical Formula 4-xi]



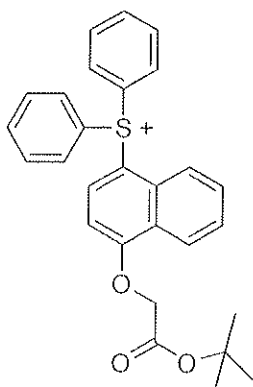
[Chemical Formula 4-xii]



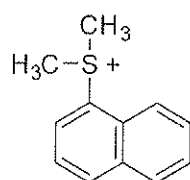
[Chemical Formula 4-xiii]



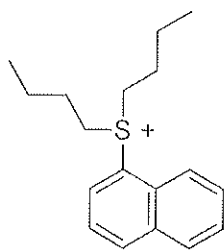
[Chemical Formula 4-xiv]



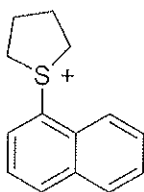
[Chemical Formula 4-xv]



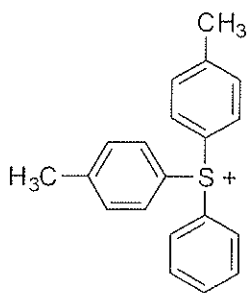
[Chemical Formula 4-xvi]



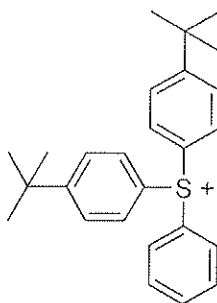
[Chemical Formula 4-xvii]



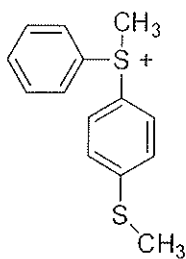
[Chemical Formula 4-xviii]



[Chemical Formula 4-xix]

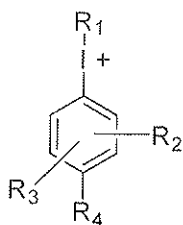


[Chemical Formula 4-xx]

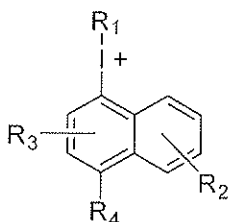


Furthermore, as the organic counterion, an one selected from the group consisting of ions represented by the following formulas (5a) and (5b):

[Chemical Formula 5a]



[Chemical Formula 5b]



In the formulas (5a) and (5b), R<sub>1</sub> represents any one selected from the group consisting of a hydrogen atom, an alkyl group, an allyl group, a perfluoroalkyl group, an aryl group and combinations thereof.

R<sub>2</sub> and R<sub>3</sub> each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an allyl group, a perfluoroalkyl group, an aryl group and combinations thereof.

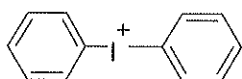
R<sub>4</sub> represents any one selected from the group consisting of a halogen atom, an alkyl group, an alkoxy group, an aryl group, a thioalkoxy group, an alkoxycarbonylmethoxy group, a thiophenoxy group and combinations thereof.

In the formulas (5a) and (5b), examples of the alkyl group include a methyl group, an ethyl group, a propyl group, an isopropyl group, an n-butyl group, a phenyl group, a hexyl group, and an octyl group; and examples of the alkoxy group include a methoxy group, an ethoxy group, a propoxy group, a butoxy group, a hexyloxy group, and an

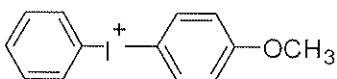
octyloxy group.

Furthermore, the organic counterion represented by the formula (5a) or (5b) may be any one selected from the group consisting of compounds represented by the following formula (5-i) to (5-ix):

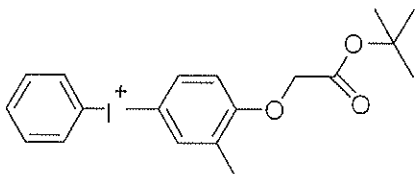
[Chemical Formula 5-i]



[Chemical Formula 5-ii]



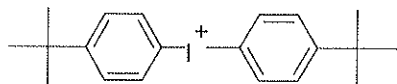
[Chemical Formula 5-iii]



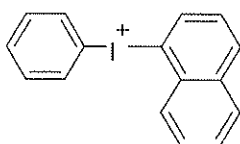
[Chemical Formula 5-iv]



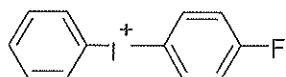
[Chemical Formula 5-v]



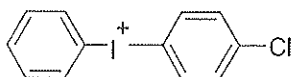
[Chemical Formula 5-vi]



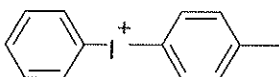
[Chemical Formula 5-vii]



[Chemical Formula 5-viii]



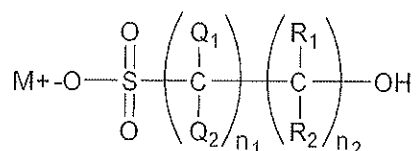
[Chemical Formula 5-ix]



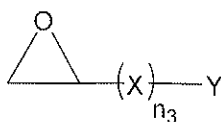
The method for producing a photoacid generator includes a first step of allowing a hydroxysulfonic acid salt to react with oxirane and producing a hydroxyethoxysulfonic acid salt; and a second step of subjecting the hydroxyethoxysulfonic acid salt thus produced to a substitution reaction of the cation, and thereby producing a compound represented by the formula (1).

In the first step, the hydroxysulfonic acid salt is allowed to react with oxirane, and thus a hydroxyethoxysulfonic acid salt is produced. The hydroxysulfonic acid salt may be represented by the following formula (6), the oxirane may be represented by the following formula (7), and the hydroxyethoxysulfonic acid salt may be represented by the following formula (8):

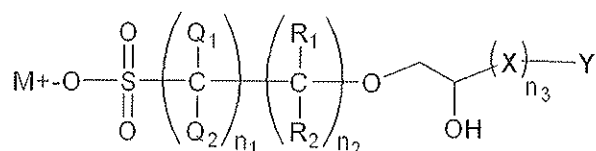
[Chemical Formula 6]



[Chemical Formula 7]



[Chemical Formula 8]



In the formulas (6) to (8), Y, X, R<sub>1</sub>, R<sub>2</sub>, n<sub>1</sub> and n<sub>2</sub> have the same meanings as defined for Y, X, R<sub>1</sub>, R<sub>2</sub>, n<sub>1</sub> and n<sub>2</sub> in the formula (1), and therefore, specific descriptions thereof will not be repeated here.

However, M<sup>+</sup> in the formulas (6) to (8) represents an alkali metal ion, and specific examples include Li<sup>+</sup>, K<sup>+</sup>, and Na<sup>+</sup>, while Na<sup>+</sup> is preferred.

The oxirane and the hydroxysulfonic acid salt may be allowed to react at a weight ratio of 1:1 to 1:3, and may be allowed to react at a weight ratio of 1:1.1 to 1:1.5. When the oxirane and the hydroxysulfonic acid salt are allowed to react at the weight ratio described above, the two compounds can be all consumed, and the efficiency of the reaction can be increased.

In the first step, the hydroxysulfonic acid salt and oxirane can be allowed to react in the presence of any one catalyst selected from the group consisting of an acidic catalyst and a basic catalyst. As the acidic catalyst, any one selected from the group consisting of sulfuric acid, hydrochloric acid, phosphoric acid, nitric acid, Lewis acid (BF<sub>3</sub>, AlCl<sub>3</sub>, FeCl<sub>3</sub> or the like), and combinations thereof can be used, and as the basic catalyst, any one selected from the group consisting of NaH, KH, NaOMe, KOBut (potassium tert-butoxide), organic bases (Et<sub>3</sub>N (triethylamine), DIPEA (N,N-diisopropylethylamine), DBU (1,8-Diazabicyclo[5.4.0]undec-7-ene), and the like), and combinations thereof can be used. When a catalyst is used in the first step reaction, the desired product can be obtained in the minimum reaction time, and thus, the yield of the reaction can be increased.

Furthermore, the hydroxysulfonic acid salt and oxirane and the catalyst can be

allowed to react at a molar ratio of 1:0.05 to 1:2, and preferably can be allowed to react at a molar ratio of 1:0.1 to 1:1. The hydroxysulfonic acid salt and oxirane and the catalyst are allowed to react at the molar ratio described above, the reaction time can be accelerated, and the removal of residual catalyst may be achieved out more easily.

The reaction of the first step may be carried out in a solvent, and as the solvent, any one selected from the group consisting of esters, ethers, lactones, ketones, amides, alcohols, and combinations thereof can be used. Preferably, the solvent may be any one selected from the group consisting of dichloromethane, chloroform, dichloroethane, acetonitrile, toluene, methyl acetate, ethyl acetate, and combinations thereof.

Specifically, the reaction of the first step may include a process of dissolving the hydroxysulfonic acid salt and oxirane in a solvent, introducing the catalyst, and then allowing the mixture to react under stirring.

The stirring may be carried out at a temperature of 0°C to 100°C for 1 to 48 hours, and may be carried out at a temperature of 0°C to 40°C for 1 to 12 hours. When the process of stirring is achieved in the temperature and time ranges described above, the yield of the product can be increased, and the formation of side products may be minimized.

After completion of the reaction, the solvent is removed from the reaction liquid, the residue is made into a slurry in ethyl ether, the slurry is filtered, and then the filter cake is washed using ethyl ether and vacuum dried. Thus, the hydroxyethoxysulfonic acid salt can be produced.

In the second step, the hydroxyethoxysulfonic acid salt thus produced is subjected to a substitution reaction of the cation, and thus a compound represented by the formula (1) is produced.

The reaction for substituting the cation of the hydroxyethoxysulfonic acid salt can

be carried out by allowing the hydroxyethoxysulfonic acid salt to react with a compound represented by the following formula (9):

[Chemical Formula 9]



wherein in the formula (9), Z<sup>-</sup> represents any one selected from the group consisting of (OSO<sub>2</sub>CF<sub>3</sub>)<sup>-</sup>, (OSO<sub>2</sub>C<sub>4</sub>F<sub>9</sub>)<sup>-</sup>, (OSO<sub>2</sub>C<sub>8</sub>F<sub>17</sub>)<sup>-</sup>, (N(CF<sub>3</sub>)<sub>2</sub>)<sup>-</sup>, (N(C<sub>2</sub>F<sub>5</sub>)<sub>2</sub>)<sup>-</sup>, (N(C<sub>4</sub>F<sub>9</sub>)<sub>2</sub>)<sup>-</sup>, (C(CF<sub>3</sub>)<sub>3</sub>)<sup>-</sup>, (C(C<sub>2</sub>F<sub>5</sub>)<sub>3</sub>)<sup>-</sup>, (C(C<sub>4</sub>F<sub>9</sub>)<sub>3</sub>)<sup>-</sup>, F<sup>-</sup>, Cl<sup>-</sup>, Br<sup>-</sup>, I<sup>-</sup>, BF<sub>4</sub><sup>-</sup>, AsF<sub>6</sub><sup>-</sup> and PF<sub>6</sub><sup>-</sup>.

A<sup>+</sup> is an organic counterion, and since the definition of the organic counterion is the same as described in connection with the formula (1), specific description thereof will not be repeated here.

The hydroxyethoxysulfonic acid salt and the compound represented by the formula (9) can be used at a molar ratio of 1:1 to 4:1, and preferably at a molar ratio of 1:1 to 2:1. When the compounds are used at the molar ratio described above, the reaction treatment time can be minimized, and side reactions caused by excessive use of the reactants can be suppressed.

The substitution reaction can be carried out using a recrystallization method, or a method of using a mixture of a solvent which well dissolves an obtained salt (good solvent) and a solvent which dissolves the salt poorly, to solidify the reaction product, and collecting the reaction product. A method of extracting the reaction product with a solvent, or a method of concentrating and collecting the reaction product can also be used.

Preferably, the substitution reaction can be carried out by dissolving the reactants in dichloromethane and water to form two layers, and then allowing the substitution to occur by stirring, and when such a two-layer reaction method is used, it is advantageous in that any additional methods for the separation of the product are not required. The stirring may be carried out in 2 to 6 hours, and may also be carried out in 2 to 4 hours. When the

reaction is carried out in the time range described above, there is an effect that the yield of the product can be increased to the maximum.

When the compound represented by the formula (1) is produced through the production method described above, the compound represented by the formula (1) can be produced by a simple method, and the compound can be produced using an epoxy compound, which is industrially easily available.

The resist composition according to another embodiment of the present invention includes a photoacid generator represented by the formula (1). The resist composition depends on the conventional constitution of resist compositions, and therefore, specific description thereof will not be repeated here.

The photoacid generator of the present invention can maintain an appropriate contact angle at the time of ArF liquid immersion lithography, can reduce defects occurring during liquid immersion lithography, and has excellent solubility in resist solvents and excellent compatibility with resins. Furthermore, the photoacid generator can be produced by an efficient and simple method using an epoxy compound, which is industrially easily available.

## EXAMPLES

Hereinafter, the present invention will be described in detail by way of Examples, so that a person having ordinary skill in the art to which the present invention is pertained can easily carry out the invention. However, the present invention may be realized in various different forms, and is not intended to be limited to the Examples described herein.

[Synthesis of photoacid generator]

(Synthesis Example 1)

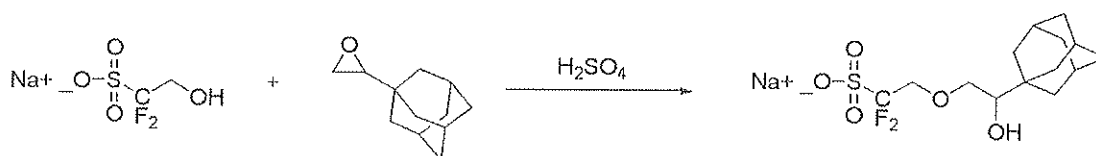
<Step 1>

As shown in the following reaction scheme (1-1), 20 g of 1,1-difluoro-2-hydroxyethanesulfonic acid sodium salt and 19.4 g of 2-adamantan-1-yloxirane were dissolved in 300 ml of dichloroethane, and the solution was stirred at normal temperature. 1 ml of sulfuric acid was slowly added dropwise to the mixture at normal temperature, and then the mixture was stirred for 2 hours.

After completion of the reaction, the reaction solvent was removed, and the residue was prepared into a slurry in ethyl ether and was filtered. After filtering, the filter cake was washed with distilled water and ethyl ether, and was vacuum dried. Thus, 33.5 g (yield 85%) of 2-(2-adamantan-1-yl-2-hydroxyethoxy)-1,1-difluoroethanesulfonic acid sodium salt was obtained, and its structure was confirmed by  $^1\text{H}$ -NMR.

$^1\text{H}$ -NMR (dimethyl sulfoxide- $d_6$ , tetramethylsilane):  $\delta(\text{ppm})$  1.11-1.64(m, 15H), 3.49-3.55 (m, 3H), 4.25(t, 2H)

[Reaction Scheme 1-1]



<Step 2>

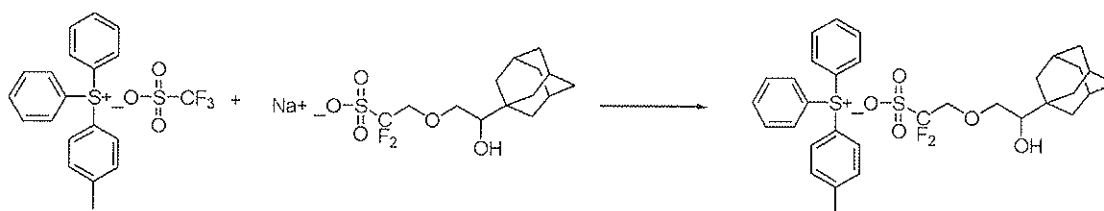
As shown in the following reaction scheme (1-2), 10 g of the 2-(2-adamantan-1-yl-2-hydroxyethoxy)-1,1-difluoroethanesulfonic acid sodium salt produced in the Step 1, and 10.5 g of diphenyl methylphenyl sulfonium trifluoromethane sulfonate salt were dissolved in 100 ml of dichloromethane and 100 ml of water, and the solution was vigorously stirred for 3 hours to carry out a two-layer reaction.

After completion of the stirring, an aliquot of the organic layer was extracted to check the extent of reaction progress by  $^{19}\text{F}$ -NMR. When the reaction was completed, the organic layer was collected, and the solvent was removed. The residue was washed with

dichloromethane, which was a good solvent, and with hexane, which was a poor solvent, the solvents were removed, and the residue was dried under reduced pressure. Thus, 16 g (yield 96%) of 2-(2-adamantan-1-yl-2-hydroxyethoxy)-1,1-difluoroethane sulfonic acid diphenyl fluorophenyl sulfonium salt was obtained, and its structure was confirmed by  $^1\text{H}$ -NMR.

$^1\text{H}$ -NMR (chloroform- $\text{d}_3$ , tetramethylsilane):  $\delta(\text{ppm})$  1.11-1.64(m, 15H), 3.49-3.55(m, 3H), 4.25(t, 2H), 7.48(d, 2H), 7.65-7.76(m, 12H)

[Reaction Scheme 1-2]



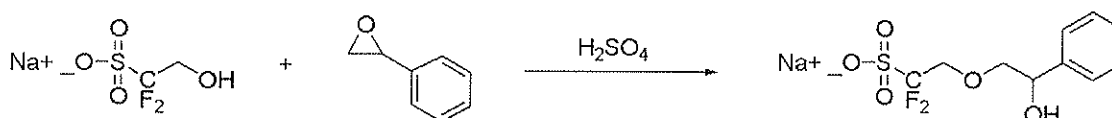
(Synthesis Example 2)

<Step 1>

As shown in the following reaction scheme (2-1), synthesis was carried out in the same manner as in Step 1 of Synthesis Example 1, except that 2-phenyloxirane was used in place of the 2-adamantanyloxirane used in Step 1 of Synthesis Example 1. Thus, 1,1-difluoro-2-(2-hydroxy-2-phenylethoxy)ethanesulfonic acid sodium salt was obtained, and its structure was confirmed by  $^1\text{H}$ -NMR.

$^1\text{H}$ -NMR (dimethyl sulfoxide- $\text{d}_6$ , tetramethylsilane):  $\delta(\text{ppm})$  3.86(dd, 2H), 4.26(t, 2H), 4.85(t, 1H), 7.18-7.23(m, 5H)

[Reaction Scheme 2-1]

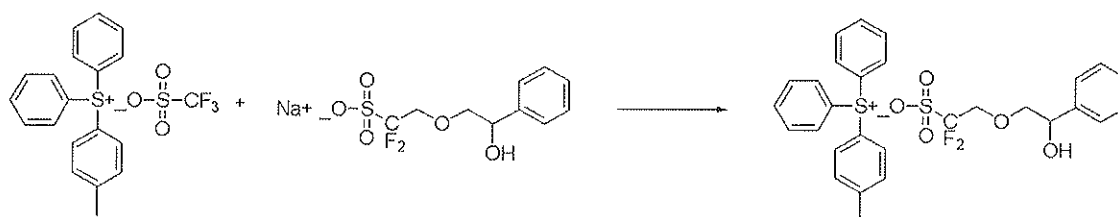


<Step 2>

As shown in the following reaction scheme (2-2), the 1,1-difluoro-2-(2-hydroxy-2-phenylethoxy)ethanesulfonic acid sodium salt produced in Step 1 was allowed to react with diphenyl methylphenyl sulfonium trifluoromethane sulfonate in the same manner as in Step 2 of Synthesis Example 1, and thus 1,1-difluoro-2-(2-hydroxy-2-phenyl-ethoxy)-ethanesulfonic acid diphenyl fluorophenyl sulfonium salt was obtained. Its structure was confirmed by  $^1\text{H-NMR}$ .

$^1\text{H-NMR}$  (chloroform- $\text{d}_3$ , tetramethylsilane):  $\delta(\text{ppm})$  3.86(dd, 2H), 4.26(t, 2H), 4.85(t, 1H), 7.18-7.48(m, 7H), 7.65-7.76(m, 12H)

[Reaction Scheme 2-2]



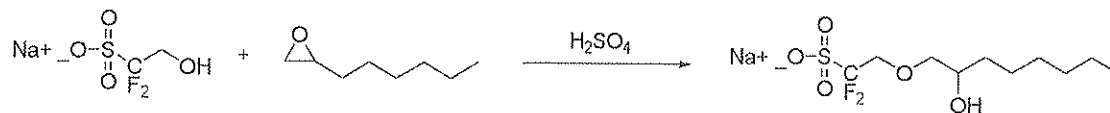
(Synthesis Example 3)

<Step 1>

As shown in the following reaction scheme (3-1), synthesis was carried out in the same manner as in Step 1 of Synthesis Example 1, except that 2-hexyloxirane was used in place of the 2-adamantanyloxirane used in Step 1 of Synthesis Example 1, and thus 1,1-difluoro-2-(2-hydroxyoctyloxy)ethanesulfonic acid sodium salt was obtained. Its structure was confirmed by  $^1\text{H-NMR}$ .

$^1\text{H-NMR}$  (dimethyl sulfoxide- $\text{d}_6$ , tetramethylsilane):  $\delta(\text{ppm})$  0.95-1.45(m, 13H), 3.49-3.55(m, 3H), 4.25(t, 2H)

[Reaction Scheme 3-1]

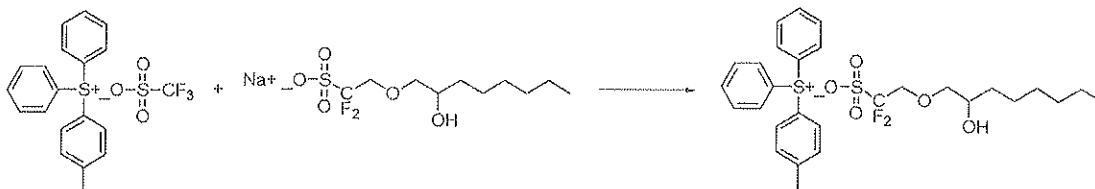


#### <Step 2>

As shown in the following reaction scheme (3-2), the 1,1-difluoro-2-(2-hydroxyoctyloxy)ethanesulfonic acid sodium salt produced in Step 1 was allowed to react with diphenyl methylphenyl sulfonium trifluoromethane sulfonate in the same manner as in Step 2 of Synthesis Example 1, and thus 1-difluoro-2-(2-hydroxyoctyloxy)-ethanesulfonic acid diphenyl fluorophenyl sulfonium salt was obtained. Its structure was confirmed by  $^1\text{H}$ -NMR.

$^1\text{H}$ -NMR (chloroform- $\text{d}_3$ , tetramethylsilane):  $\delta(\text{ppm})$  10.95-1.45(m, 13H), 3.49-3.55(m, 3H), 4.25(t, 2H), 7.48(d, 2H), 7.65-7.76(m, 12H)

#### [Reaction Scheme 3-2]



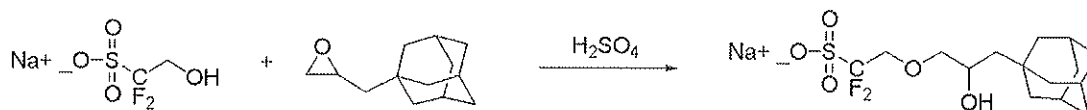
#### (Synthesis Example 4)

##### <Step 1>

As shown in the following reaction scheme (4-1), synthesis was carried out in the same manner as in Step 1 of Synthesis Example 1, except that 2-adamantan-1-ylmethyloxirane was used in place of the 2-adamantanyloxirane used in Step 1 of Synthesis Example 1, and thus 2-(3-adamantan-1-yl-2-hydroxypropoxy)-1,1-difluoroethane sulfonic acid sodium salt was obtained. Its structure was confirmed by  $^1\text{H}$ -NMR.

<sup>1</sup>H-NMR (dimethyl sulfoxide-d<sub>6</sub>, tetramethylsilane): δ(ppm) 1.17-1.58(m, 17H), 3.49-3.55 (m, 3H), 4.25(t, 2H)

[Reaction Scheme 4-1]

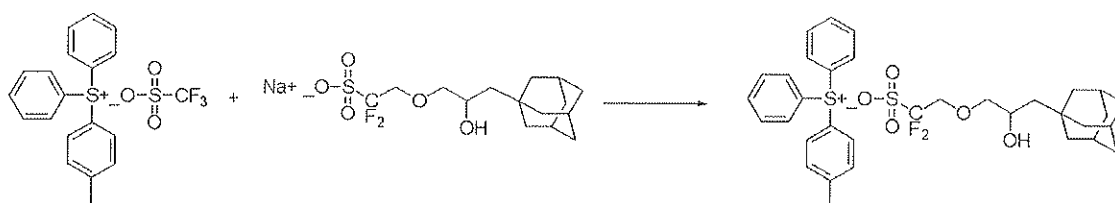


<Step 2>

As shown in the following reaction scheme (4-2), the 2-(3-adamantan-1-yl-2-hydroxypropoxy)-1,1-difluoroethanesulfonic acid sodium salt produced in Step 1 was allowed to react with diphenyl methylphenyl sulfonium trifluoromethane sulfonate in the same manner as in Step 2 of Synthesis Example 1. Thus, 2-(3-adamantan-1-yl-2-hydroxypropoxy)-1,1-difluoroethanesulfonic acid diphenyl fluorophenyl sulfonium salt was obtained. Its structure was confirmed by <sup>1</sup>H-NMR.

<sup>1</sup>H-NMR (chloroform-d<sub>3</sub>, tetramethylsilane): δ(ppm) 1.17-1.58(m, 17H), 3.49-3.55(m, 3H), 4.25(t, 2H), 7.48(d, 2H), 7.65-7.76(m, 12H)

[Reaction Scheme 4-2]



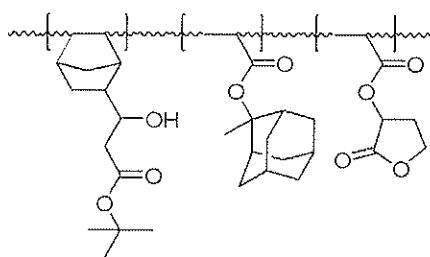
[Resin Synthesis Example]

3-Bicyclo[2.2.1]hept-5-en-2-yl-3-hydroxypropionic acid t-butyl ester (hereinafter, referred to as BHP), 1-methyladamantan acrylate, and γ-butyrolactonemethyl acrylate were introduced at a molar ratio of 1:1:1. 1,4-Dioxane was added as a polymerization solvent in an amount of 300 parts by weight relative to 100 parts by weight of the total

amount of the reaction monomers, azobisisobutyronitrile was added as an initiator in an amount of 4 molar parts relative to 100 molar parts of the total reaction monomers, and the mixture was allowed to react for 16 hours at 65°C.

After the reaction, the reaction solution was precipitated with n-hexane, and the precipitate was removed and dried in a vacuum. Thus, a copolymer represented by the following formula (10) and having a weight average molecular weight of about 8,500 g/mol was obtained.

[Chemical Formula 10]



[Experiment Examples]

(Example 1)

100 Parts by weight of the resin obtained in the Resin Synthesis Example, 4 parts by weight of the 2-(2-adamantan-1-yl-2-hydroxyethoxy)-1,1-difluoroethanesulfonic acid diphenyl fluorophenyl sulfonium salt produced in Synthesis Example 1 as a photoacid generator, and 0.5 parts by weight of tetramethylammonium hydroxide as a basic additive were dissolved in 1000 parts by weight of propylene glycol methyl ether acetate, and then the solution was filtered through a 0.2-μm membrane filter. Thus, a resist composition was prepared.

The resist composition thus obtained was applied on a substrate using a spinner, and was dried at 110°C for 90 seconds to form a film having a thickness of 0.20 μm. The film thus formed was exposed using an ArF excimer laser stepper (lens aperture number:

0.78), and then the film was heat treated for 90 seconds at 110°C. Subsequently, the film was developed with a 2.38 wt% aqueous solution of tetramethylammonium hydroxide for 40 seconds, and was washed and dried. Thus, a resist pattern was formed.

(Example 2)

A resist composition was prepared in the same manner as in Example 1, except that the photoacid generator produced in Synthesis Example 2 was used in place of the photoacid generator that was produced in Synthesis Example 1 and used in Example 1. Thus, a resist pattern was formed.

(Example 3)

A resist composition was prepared in the same manner as in Example 1, except that the photoacid generator produced in Synthesis Example 4 was used in place of the photoacid generator that was produced in Synthesis Example 1 and used in Example 1. Thus, a resist pattern was formed.

(Comparative Example)

A resist composition was prepared in the same manner as in Example 1, except that triphenylsulfonium triflate was used in place of the photoacid generator that was produced in Synthesis Example 1 and used in Example 1. Thus, a resist pattern was formed.

Various evaluations were carried out for the resist patterns produced in Examples 1 to 3. The results are presented in the following Table 1.

In the following Table 1, the amount of exposure used to form a 0.10- $\mu$ m line-and-space (L/S) pattern after development at a line width of 1:1 was designated as the optimum amount of exposure, and this optimum amount of exposure was designated as sensitivity. The minimum pattern dimension resolved at this time was designated as resolution.

Furthermore, in the case of line edge roughness (LER), the pattern roughness in the

0.10- $\mu\text{m}$  line-and-space (L/S) pattern formed after development was observed, and the LER was measured (a smaller number indicates superior LER).

[Table 1]

|                          | Resin<br>(100 parts<br>by weight) | PAG<br>(parts by<br>weight) | Base<br>(parts by<br>weight) | Sensitivity<br>( $\text{mJ}/\text{cm}^2$ ) | Resolution<br>(nm) | LER |
|--------------------------|-----------------------------------|-----------------------------|------------------------------|--------------------------------------------|--------------------|-----|
| Example 1                | Resin<br>Synthesis<br>Example     | 4.0                         | 0.5                          | 12                                         | 80                 | 4   |
| Example 2                | Resin<br>Synthesis<br>Example     | 4.0                         | 0.5                          | 13                                         | 80                 | 5   |
| Example 3                | Resin<br>Synthesis<br>Example     | 4.0                         | 0.5                          | 14                                         | 70                 | 3   |
| Comparative<br>Example 1 | Resin<br>Synthesis<br>Example     | 4.0                         | 0.5                          | 17                                         | 100                | 7   |

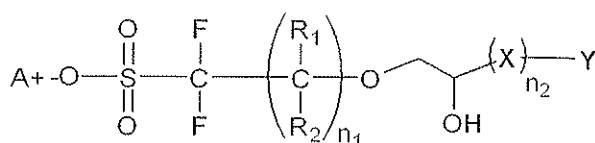
It was confirmed that the resist compositions prepared in Examples 1 to 3 have satisfactory developability with an aqueous solution of tetramethylammonium hydroxide, and satisfactory adhesiveness of the formed resist pattern to a substrate, as compared with the resist composition prepared in Comparative Example 1. It can be seen from the results of Table 1 that the resist compositions prepared in Examples 1 to 3 have superior sensitivity, resolution and LER characteristics as compared with the resist composition prepared in Comparative Example 1.

Preferred embodiments of the present invention have been described in detail in the above, but the scope of the invention is not limited to the specific details and representative embodiments shown and described herein. Accordingly, various modifications may be made without departing from the spirit or scope of the general inventive concept as defined by the appended claims and their equivalents.

## CLAIMS

1. A photoacid generator represented by the following formula (1):

[Chemical Formula 1]



wherein in the formula (1),

Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cycloalkyl group, a heterocycloalkyl group, an aryl group and a heteroaryl group;

X represents any one selected from the group consisting of an alkanediyl, an alkenediyl, NR', S, O, CO and combinations thereof, while R' represents any one selected from the group consisting of a hydrogen atom and an alkyl group;

R<sub>1</sub> and R<sub>2</sub> each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen group, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group and a thio group;

n<sub>1</sub> represents an integer or 1 or 2;

n<sub>2</sub> represents an integer from 0 to 5; and

A<sup>+</sup> represents an organic counterion.

2. The photoacid generator according to claim 1, wherein

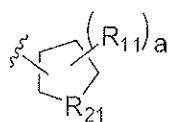
Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cyclopentyl group, a cyclohexyl group, a

decahydronaphthalene group, an octahydro-1H-indene group, an adamantyl group, a norbornyl group, a tetrahydrofuran group, a polycyclic cycloalkyl group containing a norbornyl group having 10 to 30 carbon atoms, a phenyl group, a naphthyl group, a biphenyl group, an anthryl group, a phenanthrene group, a fluorenyl group, a pyrene group, a phenalene group, an indene group, a biphenylene group, a diphenylmethyl group, a tetrahydronaphthyl group, a dihydroanthryl group, a tetraphenylmethyl group and a triphenylmethyl group.

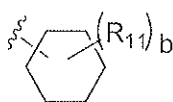
3. The photoacid generator according to claim 1, wherein

Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, and groups represented by the following formulas (1-a) to (1-i) and formulas (2-a) to (2-l):

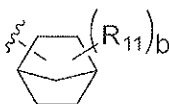
[Chemical Formula 1-a]



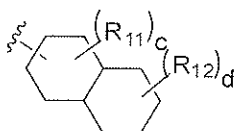
[Chemical Formula 1-b]



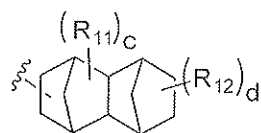
[Chemical Formula 1-c]



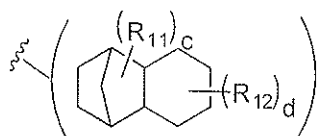
[Chemical Formula 1-d]



[Chemical Formula 1-e]



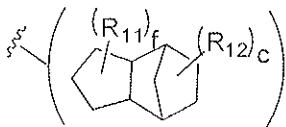
[Chemical Formula 1-f]



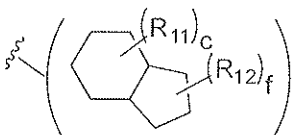
[Chemical Formula 1-g]



[Chemical Formula 1-h]



[Chemical Formula 1-i]



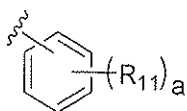
wherein in the formulas (1-a) to (1-i),

$R_{11}$  and  $R_{12}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group, a thio group, a methylthio group, a methoxy group,  $OR'$ ,  $COR'$ ,  $COOR'$ , O and S, while  $R'$  represents any one selected from the group consisting of an alkyl group and an aryl group;

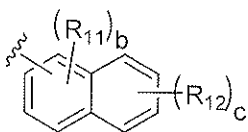
$R_{21}$  represents any one selected from the group consisting of  $CR_{24}R_{25}$ , O, CO, S and  $NR_{23}$ ;  $R_{23}$  to  $R_{25}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group and an aryl group;

a, c and d each independently represent an integer from 0 to 9; b represents an integer from 0 to 11; e represents an integer from 0 to 15; f represents an integer from 0 to 7; and  $0 \leq c+d \leq 17$ , while  $0 \leq c+f \leq 15$ ;

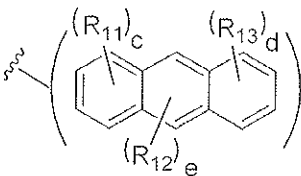
[Chemical Formula 2-a]



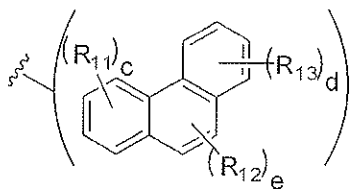
[Chemical Formula 2-b]



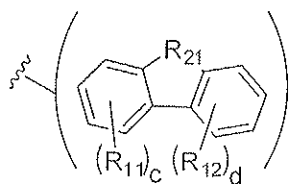
[Chemical Formula 2-c]



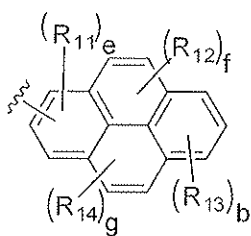
[Chemical Formula 2-d]



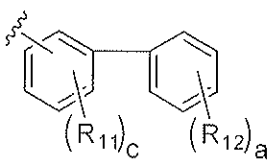
[Chemical Formula 2-e]



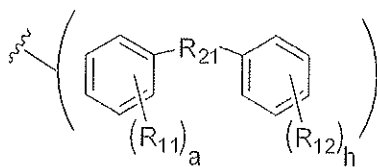
[Chemical Formula 2-f]



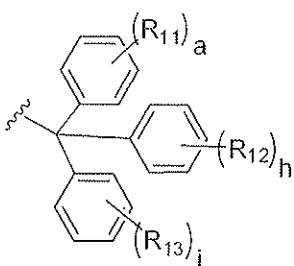
[Chemical Formula 2-g]



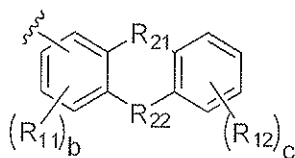
[Chemical Formula 2-h]



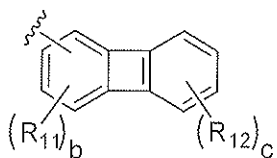
[Chemical Formula 2-i]



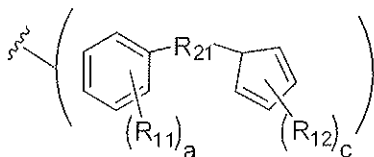
[Chemical Formula 2-j]



[Chemical Formula 2-k]



[Chemical Formula 2-l]



wherein in the formulas (2-a) to (2-l),

$R_{11}$ ,  $R_{12}$ ,  $R_{13}$  and  $R_{14}$  each independently represent any one selected from the group consisting of an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a cyano group, a nitro group, an amino group and a thio group;

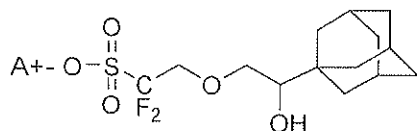
$R_{21}$  and  $R_{22}$  each independently represent any one selected from the group consisting of  $CR_{24}R_{25}$ , O, CO, S and  $NR_{23}$ ;  $R_{23}$  to  $R_{25}$  each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group and an aryl group;

a, h and i each independently represent an integer from 0 to 5; b represents an integer from 0 to 3; c and d each independently represent an integer from 0 to 4; e, f and g each independently represent an integer from 0 to 2; and  $0 \leq c+d+e \leq 9$ .

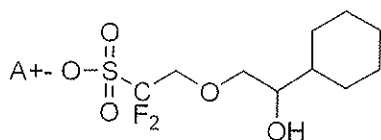
4. The photoacid generator according to claim 1, wherein the photoacid generator

is any one selected from the group consisting of compounds represented by the following formulas (3-1) to (3-12):

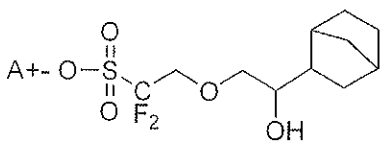
[Chemical Formula 3-1]



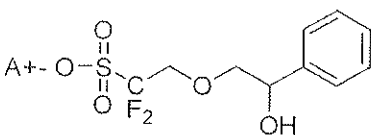
[Chemical Formula 3-2]



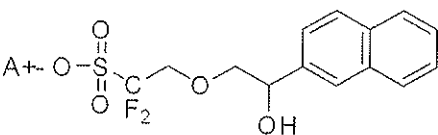
[Chemical Formula 3-3]



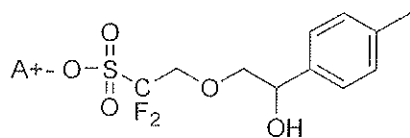
[Chemical Formula 3-4]



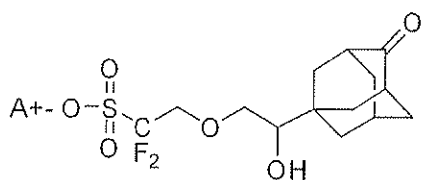
[Chemical Formula 3-5]



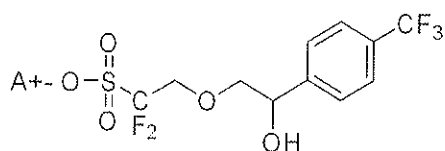
[Chemical Formula 3-6]



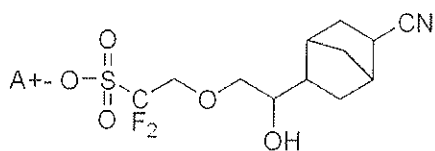
[Chemical Formula 3-7]



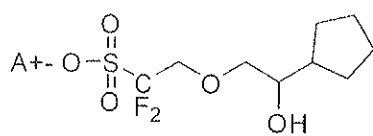
[Chemical Formula 3-8]



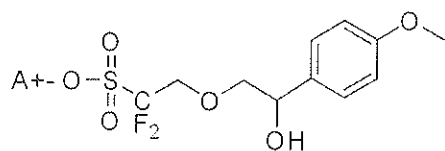
[Chemical Formula 3-9]



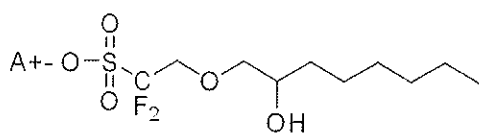
[Chemical Formula 3-10]



[Chemical Formula 3-11]

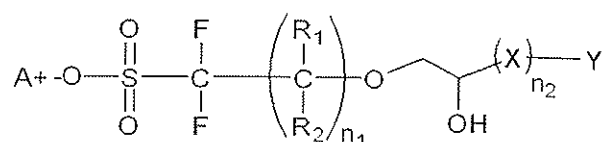


[Chemical Formula 3-12]



5. A method for producing a photoacid generator, the method comprising:  
 a first step of allowing a hydroxysulfonic acid salt to react with oxirane, and  
 thereby producing a hydroxyethoxysulfonic acid salt; and  
 a second step of subjecting the hydroxyethoxysulfonic acid salt thus produced to a  
 substitution reaction of the cation, and thereby producing a compound represented by the  
 following formula (1):

[Chemical Formula 1]



wherein in the formula (1),

Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cycloalkyl group, a heterocycloalkyl group, an aryl group and a heteroaryl group;

X represents any one selected from the group consisting of an alkanediyl, an alkenediyl, NR', S, O, CO and combinations thereof; R' represents any one selected from the group consisting of a hydrogen atom and an alkyl group;

R<sub>1</sub> and R<sub>2</sub> each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group and a thio group;

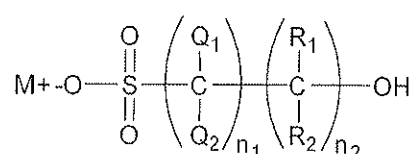
n<sub>1</sub> represents an integer or 1 or 2;

n<sub>2</sub> represents an integer from 0 to 5; and

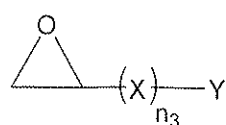
A<sup>+</sup> represents an organic counterion.

6. The method for producing a photoacid generator according to claim 5, wherein the hydroxysulfonic acid salt is represented by the following formula (6), the oxirane is represented by the following formula (7), and the hydroxyethoxysulfonic acid salt is represented by the following formula (8):

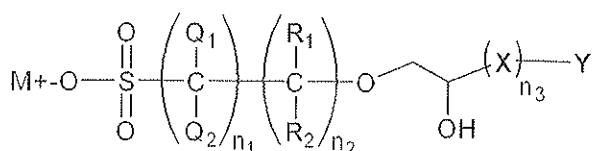
[Chemical Formula 6]



[Chemical Formula 7]



[Chemical Formula 8]



wherein in the formulas (6) to (8),

Y represents any one selected from the group consisting of an alkyl group, an alkenyl group, an alkoxy group, a cycloalkyl group, a heterocycloalkyl group, an aryl group and a heteroaryl group;

X represents any one selected from the group consisting of an alkanediyl, an alkenediyl, NR', S, O, CO and combinations thereof; R' represents any one selected from the group consisting of a hydrogen atom and an alkyl group;

R<sub>1</sub> and R<sub>2</sub> each independently represent any one selected from the group consisting of a hydrogen atom, an alkyl group, an alkoxy group, a perfluoroalkyl group, a

perfluoroalkoxy group, a halogen atom, a hydroxyl group, a carboxyl group, a cyano group, a nitro group, an amino group and a thio group;

$n_1$  represents an integer of 1 or 2;

$n_2$  represents an integer from 0 to 5; and

$M^+$  represents an alkali metal ion.

7. The method for producing a photoacid generator according to claim 5, wherein the first step is carried out by allowing the hydroxysulfonic acid salt and the oxirane to react in the presence of any one catalyst selected from the group consisting of an acidic catalyst and a basic catalyst.

8. The method for producing a photoacid generator according to claim 5, wherein the first step is carried out by mixing the hydroxysulfonic acid salt and the oxirane, and then allowing the mixture to react for 1 to 48 hours at 0°C to 100°C under stirring.

9. A resist composition comprising the photoacid generator according to any one of claims 1 to 4.